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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

OK to enter
LV
1/24/06

In re application of : **Confirmation No. 9165**
Akihisa HONGO et al. : **Attorney Docket No. 2003_0979**
Serial No. 10/620,452 : **Group Art Unit 1765**
Filed July 17, 2003 : **Examiner L. Vinh**
WAFER CLEANING APPARATUS

RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action mailed October 12, 2005, please consider the following remarks.

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975